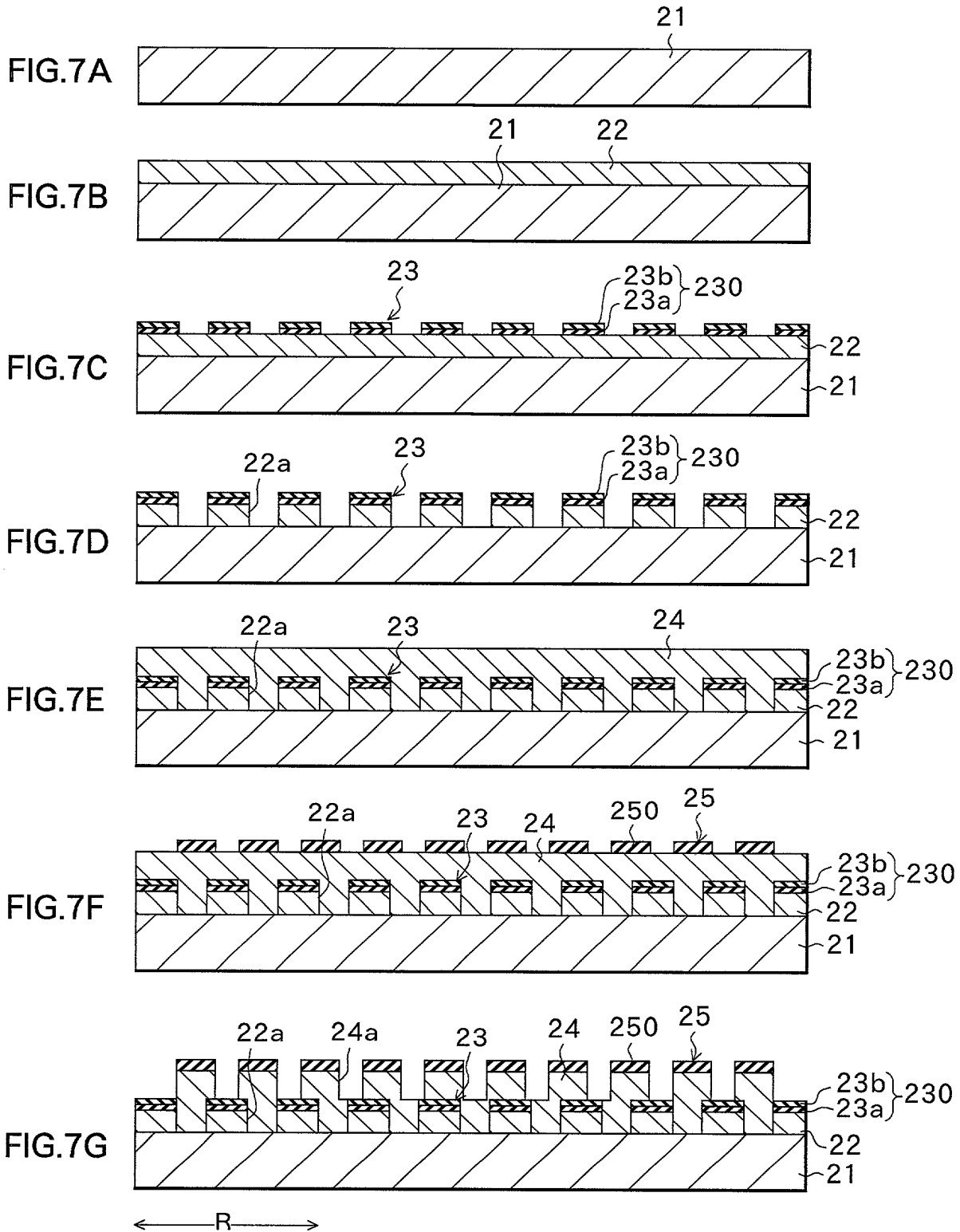




FIG.6



22a 24a 24 23a 22 21

A cross-sectional view of a semiconductor device. It shows a substrate 21 with a layer 22 on top. Layer 22 has a patterned layer 23a on top of it. Layer 23a has openings 22a. A top layer 24 is on top of layer 23a, with openings 24a. The top layer 24 has a different hatching pattern than layer 22.

$$\longleftrightarrow R \longleftrightarrow$$

20





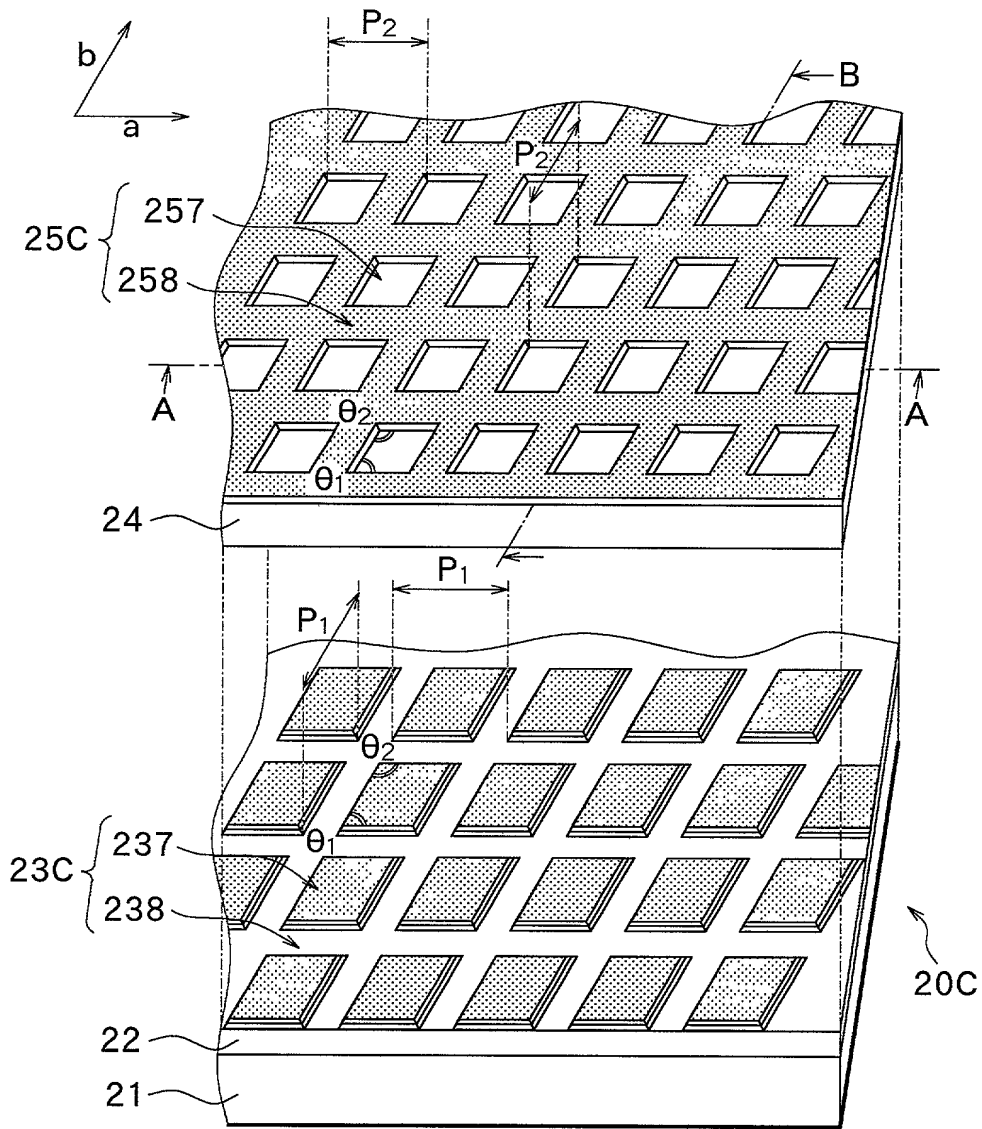


FIG.11

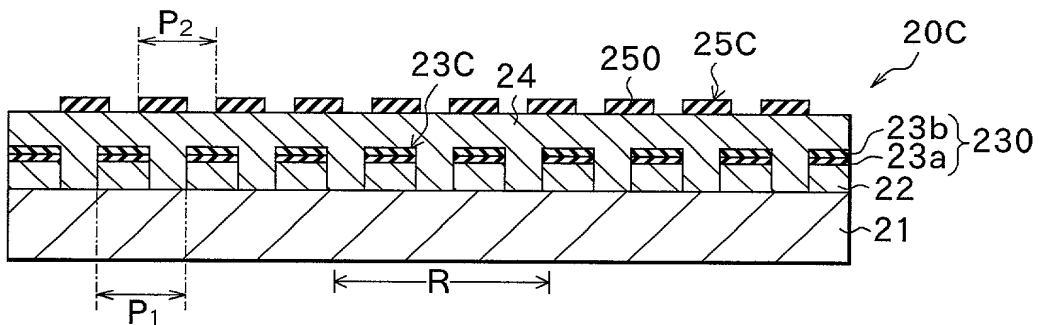


FIG.12